



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Lee et al.

GROUP: 2815

SERIAL NO: 10/603,712

EXAMINER: A.R. Wilson

FILED: 06/25/2003

FOR: A METHOD FOR IMPROVING HOLE MOBILITY ENHANCEMENT
IN STRAINED SILICON P-TYPE MOSFETSMail Stop Non-Fee Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:RESPONSE

In response to the Restriction Requirement mailed August 16, 2004, Applicants elect
Group II, Claims 43-81.

Examination on the merits is respectfully requested.

Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited
with the United States Postal Service on the date shown below with sufficient postage as first class mail in an
envelope addressed to the Mail Stop Non-Fee Amendment, Commissioner of Patents, P.O. Box 1450,
Alexandria, VA 22313-1450.

Emily C. Corell

Date:

29/13/2004